

00862.022435.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kiyoshi ARAKAWA

Application No.: 10/622,143

Filed: July 18, 2003

For: EXPOSURE APPARATUS, MAINTENANCE  
METHOD THEREFOR, SEMICONDUCTOR  
DEVICE MANUFACTURING METHOD  
USING THE APPARATUS, AND  
SEMICONDUCTOR MANUFACTURING  
FACTORY

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: Examiner: Unassigned  
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: Group Art Unit: Unassigned  
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: August 19, 2003  
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**Mail Stop Patent Application**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

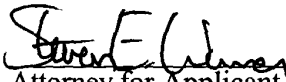
Further to the Information Disclosure Statement filed July 18, 2003, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form. A copy of the listed document is also enclosed.

This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits. Therefore, no fee under 37 C.F.R. 1.97(c)(2) is believed to be due. Nevertheless, the Commissioner may charge Deposit Account No. 06-1205, should any fee be due for filing this paper.

Applicant requests that the cited information be considered by the Examiner and that a copy of the enclosed PTO-1449 Form be initialed and returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

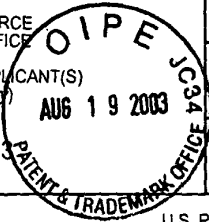
Respectfully submitted,

  
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SEW/eab

FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 00862.022435.1	APPLICATION NO. 10/622,143
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		APPLICANT Kiyoshi ARAKAWA	
Filed: August 19, 2003		FILING DATE July 18, 2003	GROUP Unassigned



U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		9-82625	03/28/1997	Japan			Yes

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)		

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.